



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Examiner: Dalei Dong

Hiroyuki Kado et al.

Group Art Unit: 2875

Serial No.: 09/744,382

Filed: January 23, 2001

For: MANUFACTURING METHOD FOR A PLASMA

DISPLAY PANEL WITH SUPERIOR

LUMINESCENCE

June 26, 2003

Irvine, California

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents PO BOX 1450 Arlington, VA 2231301459

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant wishes to bring to the attention of the U.S. Patent Office the following references, which was found during the prosecution of a co-pending Japanese Patent Application:

Japanese Laid-open Patent Application No. S61-42837 w/partial translation Japanese Laid-open Patent Application No. 5211031 w/partial translation Japanese Laid-open Patent Application No. 11144625 w/partial translation

JUL -3 2003

HOLOGY CENTER 2800

Copies of these references and a form PTO-A820 are attached.

The undersigned attorney hereby certifies that each item contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart international application not more than three months prior to filing this statement.

If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Commissioner for Patent, PO Box 1450, Arlington, VA 22313-1450, on June 26, 2003

by: James Lee

Signature

Date of Signature: June 26, 2003

Very truly yours,

SNELL & WILMER LLP

Joseph W. Price, Reg. No. 25,124

1920 Main Street, Suite 1200

Arvine, CA 92614 949/253-4920